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FAX COVER SHEET

To: Commissioner for Patents

From: Robert M. Wallace

To: Office of Initial Patent
Examination's Filing
Receipt Corrections

Total Pages, including cover letter: 5

FAX NUMBER: 703-746-9195

Document Transmitted: REQUEST FOR CORRECTION OF FILING RECEIPT

Applicant: Kenneth Collins, et al. Examiner: Unknown

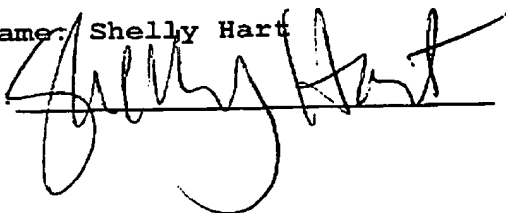
Serial No.: 10/646,612 Group Art Unit: 2817

Filed: August 22, 2003 Docket No.: 6915 P04

Title: PLASMA IMMERSION ION IMPLANTATION PROCESS USING A
CAPACITIVELY COUPLED PLASMA SOURCE HAVING LOW
DISSOCIATION AND LOW MINIMUM PLASMA VOLTAGE

I hereby certify that this paper is being transmitted by facsimile to the United States Patent & Trademark Office on the date shown below.

Printed Name: Shelly Hart

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Date: 05/14/04

PATENT

Attorney Docket No. 6915 P04
RW Ref. No. APM/001-02-CP1-4

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:)	
Kenneth COLLINS, et al.)	Group Art Unit: 1763
)	
Entitled: PLASMA IMMERSION ION)	Examiner: Unknown
IMPLANTATION PROCESS USING A)	
CAPACITIVELY COUPLED PLASMA)	
SOURCE HAVING LOW DISSOCIATION)	
AND LOW MINIMUM PLASMA VOLTAGE)	
)	
Serial No.: 10/646,612)	
)	
Filing Date: August 22, 2003)	

REQUEST FOR CORRECTION OF FILING RECEIPT

Commissioner for Patents
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Sir:

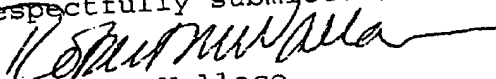
Applicants hereby request issuance of a new filing receipt to correct an error listed on the Updated Filing Receipt mailed from the USPTO on February 27, 2004. Please note the change highlighted on the enclosed copy of the Updated Filing Receipt. In particular, the correction is as follows:

The attorney docket number should read as 6915 P04. The Attorney Docket No. is currently represented as 6915 P01. On January 20, 2004, applicants erroneously requested that the Attorney Docket No. be changed from 008401 to 6915 P01. The correct Attorney Docket No. for this case is 6915 P04. Applicants apologize for any inconvenience.

Applicants respectfully request the Patent Office to correct the Filing Receipt and forward copy to Applicant.

If the Examiner should have any questions regarding the above correction, the Examiner is requested to telephone Applicant's representative at the number listed below.

Dated May 14, 2004

Respectfully submitted,

Robert M. Wallace
Reg. No. 29,119
Attorney for Applicant(s)

Please direct all telephone calls to:

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Please continue to send all correspondence to:

Patent Counsel, M/S 2061
Legal Affairs Dept.
Applied Materials, Inc.
P.O. Box 450-A
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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/646,612	08/22/2003	1763	2106	6915-P01 6915-P04	85	87	1

CONFIRMATION NO. 8623

 Patent Counsel, M/S 2061
 Legal Affairs Dept.
 Applied Materials, Inc.
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 Santa Clara, CA 95035

UPDATED FILING RECEIPT

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Date Mailed: 02/27/2004

Receipt is acknowledged of this regular Patent Application. It will be considered in its order and you will be notified as to the results of the examination. Be sure to provide the U.S. APPLICATION NUMBER, FILING DATE, NAME OF APPLICANT, and TITLE OF INVENTION when inquiring about this application. Fees transmitted by check or draft are subject to collection. Please verify the accuracy of the data presented on this receipt. If an error is noted on this Filing Receipt, please write to the Office of Initial Patent Examination's Filing Receipt Corrections, facsimile number 703-746-9195. Please provide a copy of this Filing Receipt with the changes noted thereon. If you received a "Notice to File Missing Parts" for this application, please submit any corrections to this Filing Receipt with your reply to the Notice. When the USPTO processes the reply to the Notice, the USPTO will generate another Filing Receipt incorporating the requested corrections (if appropriate).

Applicant(s)
 Kenneth S. Collins, San Jose, CA;
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APR 26 2004

MICHAELSON & WALLACE

Assignment For Published Patent Application

APPLIED MATERIALS, INC.;

Domestic Priority data as claimed by applicant

This application is a CIP of 10/164,327 06/05/2002

Foreign Applications

If Required, Foreign Filing License Granted: 11/19/2003

Projected Publication Date: 06/03/2004

Non-Publication Request: No

Early Publication Request: No

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Title

Plasma immersion ion implantation process using a capacitively coupled plasma source having low dissociation and low minimum plasma voltage

Preliminary Class

156

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Title 35, United States Code, Section 184
Title 37, Code of Federal Regulations, 5.11 & 5.15**

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